#### 502578336 11/21/2013

#### PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2

EPAS ID: PAT2624321

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
STEVEN VERHAVERBEKE	11/14/2013
HAN-WEN CHEN	11/15/2013
ROMAN GOUK	11/20/2013

#### **RECEIVING PARTY DATA**

Name:	APPLIED MATERIALS, INC.
Street Address:	3050 BOWERS AVENUE
City:	SANTA CLARA
State/Country:	CALIFORNIA
Postal Code:	95054

### PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14078373

#### **CORRESPONDENCE DATA**

**Fax Number**: (713)623-4846 **Phone**: 713-623-4844

Email: hhenderson@pattersonsheridan.com, psdocketing@pattersonsheridan.com

Correspondence will be sent via US Mail when the email attempt is unsuccessful.

Correspondent Name: PATTERSON & SHERIDAN, LLP
Address Line 1: 3040 POST OAK BLVD, SUITE 1500

Address Line 4: HOUSTON, TEXAS 77056

ATTORNEY DOCKET NUMBER:	APPM/017812US/HH
NAME OF SUBMITTER:	KEITH M. TACKETT
Signature:	/Keith M. Tackett/
	PATENT

502578336 REEL: 031651 FRAME: 0847

OP \$40,00 14078373

Date:	11/21/2013
Total Attachments: 4 source=017812USA_Assignment_EF#page source=017812USA_Assignment_EF#page source=017812USA_Assignment_EF#page source=017812USA_Assignment_EF#page	2.tif 3.tif

PATENT REEL: 031651 FRAME: 0848

Atty Dkt No.: 017812USA/ATG/ATG/ESONG

#### ASSIGNMENT FOR APPLICATION FOR PATENT

#### WHEREAS:

Names and Addresses of Inventors:

1)	Steven VERHAVERBEKE 139 Welsh Street, Unit 10 San Francisco, California 94107	2)	Han-Wen CHEN 1628 Toyon Court San Mateo, California 94403
3)	Roman GOUK 6333 Lillian Way San Jose, California 95120		

(hereinafter referred to as Assignors), have invented a certain invention entitled:

# STICTION-FREE DRYING PROCESS WITH CONTAMINANT REMOVAL FOR HIGH-ASPECT RATIO SEMICONDUCTOR DEVICE STRUCTURES

for which application for Letters Patent in the United States was filed on November 12, 2013, under Serial No. 14/078,373, executed on even date herewith; and

WHEREAS, Applied Materials, Inc., a corporation of the State of Delaware, having a place of business at 3050 Bowers Avenue, Santa Clara, California 95054 (hereinafter referred to as Assignee), is desirous of acquiring the entire right, title and interest in and to said application (hereinafter referred to as Application), and the invention disclosed therein (hereinafter referred to as Invention), and in and to all embodiments of the Invention, heretofore conceived, made or discovered by said Assignors, and in and to any and all patents, inventor's certificates and other forms of protection (hereinafter referred to as Patents) thereon granted in any and all countries and groups of countries.

NOW, THEREFORE, in consideration of good and valuable consideration acknowledged by said Assignors to have been received in full from said Assignee:

- 1. Said Assignors hereby sell, assign, transfer and convey to Assignee the full and exclusive right, title and interest (a) in and to said Application and said Invention; (b) in and to all rights to apply for patents on said Invention in any and all countries pursuant to the International Convention for the Protection of Industrial Property or otherwise; (c) in and to any and all Applications filed and any and all Patents granted on said Invention in any and all countries and groups of countries, including each and every Application filed and each and every Patent granted on any application which is a conventional, division, substitution, or continuation of said Application; and (d) in and to each and every reissue or extension of any of said Patents.
- 2. Said Assignors hereby covenant and agree to cooperate with said Assignee to enable said Assignee to enjoy to the fullest extent the right, title and interest to said Invention herein conveyed in any and all countries and groups of countries. Such cooperation by said Assignors shall include prompt production of pertinent facts and documents, giving testimony, execution of petitions, oaths, specifications, declarations or other papers, and other assistance all to the extent deemed necessary or desirable by said Assignee (a) for perfecting in said Assignee the right, title and interest herein conveyed; (b) for prosecuting any of said applications; (c) for filing and prosecuting substitute, conventional, divisional, continuing or additional applications covering said Invention; (d) for filing and prosecuting applications for reissuance of any of said Patents; (e) for interference or other priority proceedings involving said Invention; and (f) for legal proceedings involving said Invention and any application therefore and any Patents granted thereon, including without limitation opposition proceedings, cancellation proceedings, priority contests, public use proceedings, infringement actions and court actions; provided, however, that the expense incurred by said Assignors in providing such

PATENT REEL: 031651 FRAME: 0849 cooperation shall be paid for by said Assignee.

- 3. The term and covenants of this agreement shall inure to the benefit of said Assignee, its successors, assigns and other legal representatives, and shall be binding upon said Assignors, their respective heirs, legal representatives and assigns.
- 4. Said Assignors hereby warrant and represent that they have not entered and will not enter into any assignment, contract, or understanding in conflict herewith.

IN WITNESS WHEREOF, the said Assignors have executed and delivered this instrument to said Assignee on the dates indicated below.

1)	(1/14/13 (DATE)	Steven VERHAVERBEKE
2)	(DATE)	Han-Wən CHEN
3)	11/20/15 (DATE)	Roman GOUK

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Atty Dkt No.: 017812USA/ATG/ATG/ESONG

## ASSIGNMENT FOR APPLICATION FOR PATENT

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Names and Addresses of Inventors:

1)	Steven VERHAVERBEKE 139 Welsh Street, Unit 10 San Francisco, California 94107	2)	Han-Wen CHEN  1628 Toyon Court  San Matoo, California 94403 H.W.C.
3)	Roman GOUK 6333 Lillian Way San Jose, California 95120		10800 Johnson Avenue Cupertino, California 95014

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- 4. Said Assignors hereby warrant and represent that they have not entered and will not enter into any assignment, contract, or understanding in conflict herewith.

IN WITNESS WHEREOF, the said Assignors have executed and delivered this instrument to said Assignee on the dates indicated below.

1)(DATE)  H.W.C. 2) <del>Nov 15, 2013</del> (DATE)	Steven VERHAVERBEKE
Nov 15, 2013	Han-Wen CHEN
3)(DATE)	
	Roman GOUK